Docket No.: OGOSH43USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/565,767 Confirmation No. 2990

Applicant : Yuichiro Shindo

371 Filed : January 24, 2006

Art Unit : 1793

Examiner : Mark L. Shevin

Customer No. : 00270

Title : HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN

FILM COMPRSING THE SAME, AND METHOD FOR

PRODUCING HIGHLY PURE HAFNIUM

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment submitted in response to a non-final Office Action dated March 2, 2009. A Petition for a Two Month Extension of Time is filed herewith to extend the deadline for response from June 2, 2009 to August 2, 2009. Kindly amend the application as set forth below.

Remarks/Arguments begin on page 2 of this paper.